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# Direct field-to-pattern monolithic design of holographic metasurface via residual encoderdecoder convolutional neural network

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Complex-amplitude holographic metasurfaces (CAHMs) with the flexibility in modulating phase and amplitude profiles have been used to manipulate the propagation of wavefront with an unprecedented level, leading to higher image-reconstruction quality compared with their natural counterparts. However, prevailing design methods of CAHMs are based on Huygens-Fresnel theory, meta-atom optimization, numerical simulation and experimental verification, which results in a consumption of computing resources. Here, we applied residual encoder-decoder convolutional neural network to directly map the electric field distributions and input images for monolithic metasurface design. A pretrained network is firstly trained by the electric field distributions calculated by diffraction theory, which is subsequently migrated as transfer learning framework to map the simulated electric field distributions and input images. The training results show that the normalized mean pixel error is about 3% on dataset. As verification, the metasurface exhibits high similarity to the target electric field, which demonstrates the effectiveness of our design. Encouragingly, this work provides a monolithic field-to-pattern design method for CAHMs, which paves a new route for the direct reconstruction of metasurfaces.

Keywords: metasurface; holography; complex amplitude; deep learning; monolithic design

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# Introduction

Metasurfaces, as two-dimensional metamaterials, display fascinating ability in electromagnetic (EM) modulation within a sub-wavelength scale, opening up a new way for manipulating the properties of EM wave in a plane<sup>1–3</sup>. Recently, versatile metasurfaces consisting of ingenious meta-atoms with systematic arrangement have sprung up like mushrooms for shaping the EM fields by manipulating amplitude<sup>4</sup>, phase<sup>5</sup>, wavefront<sup>6</sup>, and so on. Owing to the flexible modulation of EM wave, metasurfaces have spawned a number of enchanting applications, such as perfect absorbers<sup>7,8</sup>, cloaking devices<sup>9,10</sup>, planar meta-lens<sup>11-14</sup> and meta-hologram<sup>15-17</sup>. The emergence of metasurface exhibits extraordinary capabilities in developing and improving optical and microwave devices.

Benefitting from the advantages of metasurfaces,

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holograms can be generated according to the positions and local scattering characteristics of meta-atoms arranged on a plane, which can be called metasurface holography<sup>18-20</sup>. With the unprecedented ability of reconstructing wavefronts, metasurface holography has attracted a lot of interest, which is opening new frontiers for microwave and optical devices<sup>18,19</sup>. Many fascinating works are springing up, which have greatly enriched the design and application of holograms. According to the information modulation mode, metasurface holography can be roughly divided into three categories: phase-only, amplitude-only and complex-amplitude metasurface holography<sup>21-23</sup>. Phase-only hologram engineers phase information in the image plane with amplitude as a constant, in which Gerchberg-Saxton (GS) is one of the most representative algorithms<sup>24-32</sup>. Phase profiles are modulated by various mechanisms, such as propagation phase<sup>24-26</sup>, geometric phase<sup>27-29</sup>, detour phase<sup>30-32</sup>, etc., which exhibits a flexible control strategy, thus enriching the tailoring of the image information. However, the oblivion of amplitude will compromise the imaging quality with noises that may unexpectedly appear on the presetting image. Therefore, the amplitude modulation is also introduced to engineer hologram. Similarly, amplitudeonly metasurface holography can engineer amplitude information via coding the local transmission or reflection amplitude<sup>33,34</sup>. Furthermore, combined with amplitude and phase, complex-amplitude holographic metasurfaces (CAHMs) are introduced to improve the imaging quality by carrying both phase and amplitude information<sup>35–37</sup>. The phase and amplitude profiles of metasurface can be deduced by Huygens-Fresnel theory. Rayleigh-Sommerfeld (RS) diffraction theory is a common method to design CAHMs<sup>38-40</sup>. However, the theoretical results calculated by diffraction theory are different from actual situation, which may be caused by unit coupling and unit error. Therefore, further numerical simulations are carried out to verify the hologram, thus causing a consumption of computing resources and the increased complexity of design. Fortunately, the popularity of machine learning provides an opportunity to overcome it.

Recently, machine learning has been widely used in metasurface design and applications<sup>41-43</sup>. In metasurface design, the commonest design methods are applied at the level of microstructure including forward and inverse design of meta-atoms, that is, the EM response can be directly inferred from the structure and the geometrical

parameters can be deduced from the EM spectrum<sup>44-51</sup>. The applications of machine learning empowered metaatoms effectively accelerate the design efficiency of metasurfaces by superseding the simulation process. In metasurface applications, machine learning can assist the metasurface to perceive the external environment, thus making the metasurface more intelligent to approach the usage scenario<sup>52-54</sup>. Moreover, another application of machine learning-assisted design approaches has also been proposed to design the wavefront, including the prediction of far-field or near-field distributions via neural networks without numerical simulation<sup>55-59</sup>. At the level of microstructure, the meta-atoms with specified EM responses can be fast designed by machine learning. Furthermore, the optimized meta-atoms are arranged according to the specified profiles to achieve specified function, which means that coupling between units is ignored. Therefore, the design of metasurface from a macro perspective is correspondingly proposed. By analyzing the local field distributions in space, neural network can accurately explore their internal laws and reconstruct the mapping from local field to modulator. Homoplastically, the configuration of metasurface holography also has the potential to be monolithically generated by machine learning. Metasurfaces formed by diverse meta-atoms with different arrangements will synthetically affect the electric field in space. Therefore, metasurface design from a macroscopic perspective by analyzing field and pattern will further improve the design efficiency and accuracy.

In this work, we proposed a monolithic design approach for CAHMs. Different from traditional unitbased optimization and layout, the metasurface can be monolithically generated from the electric field distributions by the deep learning network. The monolithic arrangement of metasurface is directly generated by the target electric field distribution, thus reducing the coupling between elements to simplify and accelerate the hologram metasurface design. Specifically, a residual encoder-decoder convolutional neural network (REDCNN) is employed to establish the mapping between the electric field distributions and input images. Instead of traditional Huygens-Fresnel principle and numerical simulation, the given electric field distribution can be fast converted to complex-amplitude profiles via the trained REDCNN. The schematic diagram of this work is shown in Fig. 1. Firstly, RS diffraction theory is used for generating the theoretical electric field distribution with the

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Fig. 1 | Schematic diagram of CAHM monolithic design via REDCNN model

input image. The input images are derived from MNIST, a classic dataset of handwritten numbers. The theoretical electric field distribution and input image are collected for training the REDCNN, which is preliminarily set as pretrained model. Then the metasurfaces with the theoretical complex-amplitude profiles are simulated to obtain the electric field distributions as new dataset. The pretrained model can be migrated to the new dataset by transfer learning framework, and thus only part of the input images is used to establish high-precision electric field mapping. After statistics, the normalized mean pixel error of trained REDCNN model is about 3%, meaning the high similarity between the real images and predicted images. The monolithic design method mainly focuses on the monolithic pattern of metasurface without considering the attributes of the specific elements, which will simplify the complexity of metasurface design. Also, monolithic design is to design metasurfaces at the macro level. As verification, an input image is predicted by the electric field distribution, and the corresponding metasurface is modeled. The metasurface prototypes are fabricated, simulated and measured to validate the inverse model. The reconstructed electric field of reverse-engineered metasurface exhibits high similarity to the given electric field distribution, which demonstrates the effectiveness of our model. Importantly, this work provides a monolithic design method for CAHMs, which can be easily extended to the metasurface reverse engineer of other properties.

# Holography metasurface monolithic design

# **REDCNN** design

Here, the REDCNN is employed as machine learning architecture to establish the mapping between the electric distributions and input images. As the name of the model suggests, REDCNN is based on encoder-decoder convolutional neural network with skipped residual connection. This architecture can achieve image reconstruction through feature compression and reconstruction, which has achieved certain results in medical image processing<sup>60</sup>. Owning to the image-to-image framework can be easily transplanted to another scenario, this work followed and applied this framework. The architecture of REDCNN is shown in Fig. 2(a), which includes 4 convolution down-sampling layers, 4 transposed convolution up-sampling layers, and 1 convolution full-connection layer. The electric field distribution is set as input and input image is output of REDCNN. As a down-sampling method, convolution layer can effectively extract highdimensional features of images. The schematic diagram

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Fig. 2 | REDCNN model design and feature extraction. (a) The architecture and dimension of REDCNN model. (b) The downsampling process of feature decoder. (d) Feature transfer of different channels in encoding process. (e) Feature transfer of different channels in decoding process

of feature transfer in the encoder is shown in Fig. 2(d), which can be seen that different feature information is extracted from different feature channels. For example, some feature channels focus on foreground information, while others may focus on background information. Even edge, brightness and other features are extracted into different feature channels. After the compression of the first four convolution layers, the feature graph with dimension  $[20\times20]$  is finally compressed. The downsampling process under convolution is shown in Fig. 2(b). In the down-sampling process, batch normaliza-

tion is applied to normalize the data set and average pooling layer is introduced to reduce the effect of singularities. Batch normalization can be expressed as Eq. (1).

$$y = \frac{x - U(x)}{\sqrt{Var(x)} + \varepsilon} * A + B , \qquad (1)$$

where x and y are input and output data, U(x) and Var(x) are expectation and variance of training data,  $\varepsilon$  is a constant to avoid 0 in the denominator. A and B are the weight parameters. Since it is a nonlinear mapping, Rectified Linear Unit (ReLU) is used as the activation

function which is shown in Eq. (2).

$$f(x) = \begin{cases} 0, & x \le 0 \\ x, & x > 0 \end{cases},$$
 (2)

in which x is the input data. f(x) is output of neuron. Correspondingly, the up-sampling process under transposed convolution is shown in Fig. 2(c), in which this block also includes batch normalization, average pooling layer and ReLU activation function. The schematic diagram of feature transfer in the decoder is shown in Fig. 2(e). After the restructuration of the four transposed convolution layers, the feature graph with dimension [28×28] is finally compressed. The last convolution layer realizes two-dimensional fully connection through 1×1 convolution kernel to adjust the output of the image. Henceforth, the input image can be reconstructed by REDCNN.

# Network training

The REDCNN is trained twice here, that is, deep learning pretraining and transfer learning retraining. In this work, the images are extracted from MNIST dataset. The MNIST dataset contains the images with pixels  $[28 \times 28]$ containing handwritten digits across 10 categories<sup>61</sup>. Firstly, the electric field distributions are collected by RS diffraction theory, and the initial dataset of theoretical electric field and input image is achieved. The phase and amplitude profiles calculation and electric field reconstruction can be obtained by RS diffraction theory, whose relevant equations are supplemented in Supplementary information Section 1. The collected dataset is used to train REDCNN with the training process shown in Fig. 3(a), in which the loss function value appears a downward trend. The initial MAE loss value of deep learning is 29.6, that is, 11.6% normalized mean pixel error. Mean absolute error (MAE) function is selected as the loss function which can be expressed as Eq. (3).

$$MAE = \frac{1}{n} \sum_{i=1}^{n} |p(x_i) - y_i| , \qquad (3)$$

in which *n* is the count of data,  $p(x_i)$  is the predicted value of model,  $y_i$  is the true value. After training, the MAE loss of gray image pixels reached 4.6, that is, 1.8% normalized mean pixel error, which can demonstrate the model can reconstruct the image with less loss. We define the normalized mean pixel error as the relative variation in the range of pixel changes, which can be calculate by Eq. (4).

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$$P_{\rm err} = \frac{MAE}{P_{\rm max}} , \qquad (4)$$

where  $P_{err}$  is normalized mean pixel error. MAE is the mean absolute error between the predicted value and true value.  $P_{\text{max}}$  is the max value of the range of pixel, in which the pixel value in gray image varies between [0, 255]. Moreover, the histograms of error distribution in training set and test set are shown in Fig. 3(c) and 3(d), in which the pixel error of most point is close to 0. Subsequently, the trained REDCNN is set as pretrained model for transfer learning. Part of input image is selected to simulate the electric field distributions. The simulated electric field distributions are collected as new dataset. Then, the pretrained REDCNN is migrated to retrain as transfer learning framework. The input and output of new dataset are the simulated electric fields and input images. The process of transfer learning retraining is shown in Fig. 3(b), where the gray value of pixel MAE loss dropped to 7.8 from 13.9. The normalized mean pixel error finally reached to 3%. Notably, the initial loss value has already reached 13.9, normalized mean pixel error is 5.5%. Compared to the initial loss of deep learning, the initial loss value is reduced by 6.1%, which fully demonstrates the advantages of transfer learning retraining framework. The histograms of error distribution in training set and test set by transfer learning are shown in Fig. 3(e) and 3(f), where the pixel errors of most points are also close to 0. The error histograms fully demonstrate that the model can accurately predict images with less error. Moreover, the convolutional neural network (CNN) and encoder-decoder convolutional neural network (EDCNN) as control group are also trained respectively to verify the superiority of REDCNN, which are supplemented in Supplementary information Section 2. The statistical results convincingly prove the effectiveness of this framework.

# Metasurface monolithic design and simulation

In order to further demonstrate the trained REDCNN, a metasurface in dataset is selected to verify our design. Firstly, the simulated electric field distribution is fed into the trained REDCNN as input. After this operation, the predicted gray image is output. Figure 4(a) illustrates the gray image of the input image, in which the real image is similar to predicted image with less error. The phase and amplitude profiles are calculated by RS diffraction theory, as shown in Fig. 4(b) and 4(c). The phase and amplitude of predicted image exhibit high



Fig. 3 | Training and test of the REDCNN model. (a) The variation of MAE loss value in deep learning process. (b) The variation of MAE loss value in transfer learning process. (c) The error histogram of deep learning in training set. (d) The error histogram of deep learning in test set. (e) The error histogram of transfer learning in training set. (f) The error histogram of transfer learning in test set.

similarity to real image. Figure 4(d) illustrates the theoretical electric field which is calculated by RS diffraction. The electric intensity between the real plane and predicted plane is similar. The corresponding metasurface of the predicted image is filled by meta-atoms and simulated to observe the electric field distribution. The metaatoms design is supplemented in Supplementary information Section 3. The metasurface is placed on *XOY* plane and the boundary conditions in *X*, *Y*, *Z* directions are set to free space. The full wave simulation is carried out in CST Microwave Studio. The *x*-polarized plane waves impinge on the metasurface from the +*Z* direction. E-filed monitor is set to obtain the electric field distribution. The *XOY* plane at *Z* = 50 mm is observed. The comparation of simulated results is shown in Fig. 4(e), where the similarity of electric intensity distributions demonstrated the accuracy of model. The similarity of the images is evaluated by Peak Signal-to-Noise Ratio (PSNR) and Structural SIMilarity (SSIM) respectively, which is supplemented in Supplementary information Section 4. The PSNR of the real and predicted images is 38.39 dB and the SSIM of the real and predicted images is 99.78%. According to the real and predicted images, the complex-amplitude profiles can be calculated and the metasurface can be reconstructed to generate the hologram. Furthermore, the PSNR and SSIM are also applied to evaluate the image similarity between the real data and predicted data. The PSNR of the real and predicted phase profiles, amplitude profiles, theoretical electric field distributions, and simulated electric field distributions are

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Fig. 4 | The comparison of predicted metasurface and real metasurface with error distributions. (a) Input images. (b) Phase profiles of metasurface. (c) Amplitude profiles of metasurface. (d) Theoretical electric field distributions calculated by diffraction theory. (e) Simulated electric field distributions.

25.99 dB, 44.80 dB, 44.29 dB, and 28.2861 dB, respectively. The SSIM of the real and predicted phase profiles, amplitude profiles, theoretical electric field distributions, and simulated electric field distributions are 99.97%, 99.92%, 99.92%, and 94.96% respectively. Moreover, the more comparations of real and predicted images are supplemented in Supplementary information Section 5.

# Experimental verification

Furthermore, the metasurface prototypes of the real image and predicted image are fabricated and measured. Figure 5(a) shows the photographs of fabricated metasurface prototypes. The prototypes of designed metasurfaces are fabricated using Printed Circuit Board (PCB) technology. Figure 5(b) and 5(c) illustrate the photographs of the fabricated orthogonal metal gratings. The photographs of the metasurface patterns corresponding with real image and predicted image are shown in Fig. 5(d) and 5(e). The images include  $28 \times 28$  pixels corresponding that the metasurfaces consist of  $28 \times 28$  metaatoms. Therefore, the side-length of fabricated metasurface prototype is 168 mm. All the samples are measured in microwave anechoic chamber as shown in Fig. 5(f). The sample is placed vertically on the test platform, the broadband horn antenna is vertically placed away from sample as transmitting antenna. The probe as the receiver is set to receive the EM wave and scan the electric field distribution. The polarization direction of the probe is

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Fig. 5 | Measurement verification and comparation of the metasurfaces. (a) Photograph of fabricated metasurface prototype. (b, c) Photograph of orthogonal metal gratings. (d) Photograph of real metasurface pattern. (e) Photograph of predicted metasurface pattern. (f) Electric-field measurement environment in microwave anechoic chamber. (g) Measured electric field distribution of real metasurface. (h) Measured electric field distribution of predicted metasurface. (i) The error of measured electric field distribution between the real and predicted metasurfaces

placed orthogonal to that of the transmitting antenna. The probe driven by a stepper motor is positioned 50 mm above the sample and the scanning area is  $180 \times 180$  mm. The measured results of real metasurface and predicted metasurface are shown in Fig. 5(g) and 5(h). The difference between two electric field distributions is used to detect the error between them, which is exhibited in Fig. 5(i). The error diagram between these shows a small measured error distribution, which sufficiently demonstrated our design. All the measured results verified the validity of trained REDCNN model, which can monolithically design the CAHM.

# Conclusion

In this work, we propose a monolithic design approach of CAHM via REDCNN architecture. Deep learning pretraining and transfer learning retraining frameworks are employed to establish the mapping between the electric field distributions and input images. With the trained REDCNN, the input image can be fast predicted by the electric field distributions. Owing to the unit coupling and unit error have been considered for generating electric field distribution, the prediction of input image can eliminate these effects. The training results illustrate that the normalized mean pixel error predicted by REDCNN can reach 3%, which is high accuracy for inverse design. The metasurfaces can be fast monolithically fabricated according to the input images. As verification, theory, simulation and measurement are carried out to compare the metasurfaces of real image and predicted image. All the real and predicted results exhibit a high degree of similarity, which convincedly verified our design. Here, we use REDCNN to achieve the metasurface monolithic design based on MNIST data. In the future, the data and

model can be further improved performance. About data, the more images can be expanded in dataset and the more complex patterns can be calculated in monolithic design. About model, physics-based inspired machine learning will further optimize the monolithic design. Most importantly, this work provides a new way to monolithically inverse design the holography metasurface via machine learning, which can be easily extended to the other application of metasurfaces.

# References

- Sun SL, He Q, Hao JM, Xiao SY, Zhou L. Electromagnetic metasurfaces: physics and applications. *Adv Opt Photonics* 11, 380–479 (2019).
- Luo XG. Metamaterials and metasurfaces. *Adv Opt Mater* 7, 1900885 (2019).
- Lu FF, Zhang WD, Huang LG, Liang SH, Mao D et al. Mode evolution and nanofocusing of grating-coupled surface plasmon polaritons on metallic tip. *Opto-Electron Adv* 1, 180010 (2018).
- Huang FC, Chiu CN, Wu TL, Chiou YP. A circular-ring miniaturized-element metasurface with many good features for frequency selective shielding applications. *IEEE Trans Electromagn Compat* 57, 365–374 (2015).
- Mueller JPB, Rubin NA, Devlin RC, Groever B, Capasso F. Metasurface polarization optics: independent phase control of arbitrary orthogonal states of polarization. *Phys Rev Lett* **118**, 113901 (2017).
- Jin ZW, Janoschka D, Deng JH, Ge L, Dreher P et al. Phyllotaxis-inspired nanosieves with multiplexed orbital angular momentum. *eLight* 1, 5 (2021).
- Landy NI, Sajuyigbe S, Mock JJ, Smith DR, Padilla WJ. Perfect metamaterial absorber. *Phys Rev Lett* **100**, 207402 (2008).
- Ra'di Y, Simovski CR, Tretyakov SA. Thin perfect absorbers for electromagnetic waves: theory, design, and realizations. *Phys Rev Appl* 3, 037001 (2015).
- Schurig D, Mock JJ, Justice BJ, Cummer SA, Pendry JB et al. Metamaterial electromagnetic cloak at microwave frequencies. *Science* 314, 977–980 (2006).
- Xu HX, Hu GW, Wang YZ, Wang CH, Wang MZ et al. Polarization-insensitive 3D conformal-skin metasurface cloak. *Light Sci Appl* **10**, 75 (2021).
- Lou Q, Chen ZN. Sidelobe suppression of metalens antenna by amplitude and phase controllable metasurfaces. *IEEE Trans Antennas Propag* 69, 6977–6981 (2021).
- Zhou Y, Liang GF, Wen ZQ et al. Recent research progress in optical super-resolution planar meta-lenses. *Opto-Electron Eng* 48, 210399 (2021).
- Wang YL, Fan QB, Xu T. Design of high efficiency achromatic metalens with large operation bandwidth using bilayer architecture. *Opto-Electron Adv* 4, 200008 (2021).
- Chen K, Feng YJ, Monticone F, Zhao JM, Zhu B et al. A reconfigurable active Huygens' metalens. *Adv Mater* 29, 1606422 (2017).
- Wang Q, Xu Q, Zhang XQ, Tian CX, Xu YH et al. All-dielectric meta-holograms with holographic images transforming longitudinally. ACS Photonics 5, 599–606 (2018).
- 16. Yoon G, Lee D, Nam KT, Rho J. Pragmatic metasurface holo-

### https://doi.org/10.29026/oea.2023.220148

gram at visible wavelength: the balance between diffraction efficiency and fabrication compatibility. *ACS Photonics* **5**, 1643–1647 (2018).

- Gao H, Fan XH, Xiong W, Hong MH. Recent advances in optical dynamic meta-holography. *Opto-Electron Adv* 4, 210030 (2021).
- Shang GY, Wang ZC, Li HY, Zhang K, Wu Q et al. Metasurface holography in the microwave regime. *Photonics* 8, 135 (2021).
- Wan WW, Gao J, Yang XD. Metasurface holograms for holographic imaging. *Adv Opt Mater* 5, 1700541 (2017).
- Xu K, Wang XE, Fan XH et al. Meta-holography: from concept to realization. Opto-Electron Eng 49, 220183 (2022).
- Zhao RZ, Huang LL, Wang YT. Recent advances in multi-dimensional metasurfaces holographic technologies. *PhotoniX* 1, 20 (2020).
- Jiang Q, Jin GF, Cao LC. When metasurface meets hologram: principle and advances. *Adv Opt Photonics* 11, 518–576 (2019).
- Mu YH, Zheng MY, Qi JR, Li HM, Qiu JH. A large field-of-view metasurface for complex-amplitude hologram breaking numerical aperture limitation. *Nanophotonics* 9, 4749–4759 (2020).
- Zhao WY, Jiang H, Liu BY, Song J, Jiang YY et al. Dielectric Huygens' metasurface for high-efficiency hologram operating in transmission mode. *Sci Rep* 6, 30613 (2016).
- Wang L, Kruk S, Tang HZ, Li T, Kravchenko I et al. Grayscale transparent metasurface holograms. *Optica* 3, 1504–1505 (2016).
- Arbabi A, Horie Y, Bagheri M, Faraon A. Dielectric metasurfaces for complete control of phase and polarization with subwavelength spatial resolution and high transmission. *Nat Nanotechnol* **10**, 937–943 (2015).
- Huang K, Dong ZG, Mei ST, Zhang L, Liu YJ et al. Silicon multimeta-holograms for the broadband visible light. *Laser Photonics Rev* **10**, 500–509 (2016).
- Zheng GX, Mühlenbernd H, Kenney M, Li GX, Zentgraf T et al. Metasurface holograms reaching 80% efficiency. *Nat Nanotechnol* **10**, 308–312 (2015).
- Li X, Chen LW, Li Y, Zhang XH, Pu MB et al. Multicolor 3D meta-holography by broadband plasmonic modulation. *Sci Adv* 2, e1601102 (2016).
- Khorasaninejad M, Ambrosio A, Kanhaiya P, Capasso F. Broadband and chiral binary dielectric meta-holograms. *Sci Adv* 2, e1501258 (2016).
- Min CJ, Liu JP, Lei T, Si GY, Xie ZW et al. Plasmonic nano-slits assisted polarization selective detour phase meta-hologram. *Laser Photonics Rev* 10, 978–985 (2016).
- Deng ZL, Deng JH, Zhuang X, Wang S, Li KF et al. Diatomic metasurface for vectorial holography. *Nano Lett* 18, 2885–2892 (2018).
- Butt H, Montelongo Y, Butler T, Rajesekharan R, Dai Q et al. Carbon nanotube based high resolution holograms. *Adv Mater* 24, OP331–OP336 (2012).
- Huang K, Liu H, Garcia-Vidal FJ, Hong MH, Luk'yanchuk B et al. Ultrahigh-capacity non-periodic photon sieves operating in visible light. *Nat Commun* 6, 7059 (2015).
- Huang LL, Chen XZ, Mühlenbernd H, Zhang H, Chen SM et al. Three-dimensional optical holography using a plasmonic metasurface. *Nat Commun* 4, 2808 (2013).
- Liu LX, Zhang XQ, Kenney M, Su XQ, Xu NN et al. Broadband metasurfaces with simultaneous control of phase and amplitude. *Adv Mater* 26, 5031–5036 (2014).

- Lee GY, Yoon G, Lee SY, Yun H, Cho J et al. Complete amplitude and phase control of light using broadband holographic metasurfaces. *Nanoscale* **10**, 4237–4245 (2018).
- Shen C, Xu RL, Sun JL, Wang Z, Wei S. Metasurface-based holographic display with all-dielectric meta-axilens. *IEEE Photonics J* 13, 4600105 (2021).
- Wang Q, Zhang XQ, Xu YH, Gu JQ, Li YF et al. Broadband metasurface holograms: toward complete phase and amplitude engineering. *Sci Rep* 6, 32867 (2016).
- Burch J, Di Falco A. Surface topology specific metasurface holograms. ACS Photonics 5, 1762–1766 (2018).
- 41. Li LL, Zhao HT, Liu C, Li L, Cui TJ. Intelligent metasurfaces: control, communication and computing. *eLight* **2**, 7 (2022).
- Chen ZG, Segev M. Highlighting photonics: looking into the next decade. *eLight* 1, 2 (2021).
- Krasikov S, Tranter A, Bogdanov A, Kivshar Y. Intelligent metaphotonics empowered by machine learning. *Opto-Electron Adv* 5, 210147 (2022).
- Ma W, Liu ZC, Kudyshev ZA, Boltasseva A, Cai WS et al. Deep learning for the design of photonic structures. *Nat Photonics* 15, 77–90 (2021).
- Malkiel I, Mrejen M, Nagler A, Arieli U, Wolf L et al. Plasmonic nanostructure design and characterization via deep learning. *Light Sci Appl* 7, 60 (2018).
- Peurifoy J, Shen YC, Jing L, Yang Y, Cano-Renteria F et al. Nanophotonic particle simulation and inverse design using artificial neural networks. *Sci Adv* 4, eaar4206 (2018).
- Nadell CC, Huang BH, Malof JM, Padilla WJ. Deep learning for accelerated all-dielectric metasurface design. *Opt Express* 27, 27523–27535 (2019).
- Liu DJ, Tan YX, Khoram E, Yu ZF. Training deep neural networks for the inverse design of nanophotonic structures. ACS *Photonics* 5, 1365–1369 (2018).
- Wiecha PR, Arbouet A, Girard C, Muskens OL. Deep learning in nano-photonics: inverse design and beyond. *Photonics Res* 9, B182–B200 (2021).
- Zheng ZH, Zhu SK, Chen Y, Chen HY, Chen JH. Towards integrated mode-division demultiplexing spectrometer by deep learning. *Opto-Electron Sci* 1, 220012 (2022).
- Ma TG, Tobah M, Wang HZ, Guo LJ. Benchmarking deep learning-based models on nanophotonic inverse design problems. *Opto-Electron Sci* 1, 210012 (2022).
- Qian C, Zheng B, Shen YC, Jing L, Li EP et al. Deep-learningenabled self-adaptive microwave cloak without human intervention. *Nat Photonics* 14, 383–390 (2020).
- Jia YT, Qian C, Fan ZX, Ding YZ, Wang ZD et al. In situ customized illusion enabled by global metasurface reconstruction.

# https://doi.org/10.29026/oea.2023.220148

Adv Funct Mater 32, 2109331 (2022).

- Qian C, Wang ZD, Qian HL, Cai T, Zheng B et al. Dynamic recognition and mirage using neuro-metamaterials. *Nat Commun* 13, 2694 (2022).
- Whiting EB, Campbell SD, Kang L, Werner DH. Meta-atom library generation via an efficient multi-objective shape optimization method. *Opt Express* 28, 24229–24242 (2020).
- Liu C, Yu WM, Ma Q, Li LL, Cui TJ. Intelligent coding metasurface holograms by physics-assisted unsupervised generative adversarial network. *Photonics Res* 9, B159–B167 (2021).
- Huang M, Zheng B, Cai T, Li XF, Liu J et al. Machine–learningenabled metasurface for direction of arrival estimation. *Nanophotonics* **11**, 2001–2010 (2022).
- Qie JR, Khoram E, Liu DJ, Zhou M, Gao L. Real-time deep learning design tool for far-field radiation profile. *Photonics Res* 9, B104–B108 (2021).
- Zhu S, Guo EL, Gu J, Bai LF, Han J. Imaging through unknown scattering media based on physics-informed learning. *Photonics Res* 9, B210–B219 (2021).
- Chen H, Zhang Y, Kalra MK, Lin F, Chen Y et al. Low-dose CT with a residual encoder-decoder convolutional neural network. *IEEE Trans Med Imaging* 36, 2524–2535 (2017).
- LeCun Y, Bottou L, Bengio Y, Haffner P. Gradient-based learning applied to document recognition. *Proc IEEE* 86, 2278–2324 (1998).

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#### Author contributions

R. C. Zhu and J. F. Wang proposed the original idea and supervised the project. S. B. Qu supervised the project. T. S. Qiu and D. K. Yang carried out the simulations. Z. T. Chu, T. H. Liu fabricated the samples and performed the measurements. Y. J. Han, B. Feng and H. Y. Chen provided the calculation and measurement conditions and assisted the measurement.

#### Competing interests

The authors declare no competing financial interests.

# Supplementary information

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